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S&H Form: (2/01)  
Attorney Docket No. 1082.1061

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Kazunori INOUE, et al.

Application No.: 10/627,727

Group Art Unit: 2879

Confirmation No.: 7084

Filed: July 28, 2003

Examiner: Matthew P. Hodges

For: GAS DISCHARGE PANEL SUBSTRATE ASSEMBLY, PRODUCTION METHOD  
THEREFOR AND AC TYPE GAS DISCHARGE PANEL

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 17, 2004, applicants elect Claims 1-8,  
14 and 15 of Group I, without traverse.

Respectfully submitted,

STAAS & HALSEY LLP

Date: January 10, 2005

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